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## RESPONSE AND REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. §1.116

- EXPEDITED PROCEDURE -

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Jae-ho MOON et al.

Serial No.: 09/426,644

Filed: October 25, 1999

For: A PROCESS OF MANUFACTURING FLUID JETTING APPARATUSES

**Assistant Commissioner for Patents** 

Washington, D.C. 20231

Attention: BOX AF

Sir:

This is responsive to the <u>Final</u> Office Action mailed June 19, 2001, having a shortened period for response set to expire on September 19, 2001.

The following amendments and remarks are respectfully submitted.

**IN THE CLAIMS:** 

Please **CANCEL** claims 37, 39, 41, 43, and 46 without prejudice or disclaimer, and **AMEND** claim 30, as follows:

30. (ONCE AMENDED) The process of manufacturing a plurality of fluid jetting apparatuses as claimed in claim 27, wherein:

the forming of the electrodes on the third substrate is performed by a lithography process or a wet etching process; and

the forming of the heat elements on the third substrate is performed by the lithography process, the spinning process or a lift-off process.

APPA ON WAY

graf & Appeal Brief

process

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